




Attorney Docket No. 0756-2393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2818
Ritsuko KAWASAKI et al.	)	Examiner: D. Vu
Serial No. 09/988,389	)	<u>CERTIFICATE OF MAILING</u>
Filed: November 19, 2001	)	I hereby certify that this correspondence is
For: LASER IRRADIATION METHOD AND	)	being deposited with the United States Postal
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	)	Alexandria, VA 22313-1450, on May 30, 2006
	)	

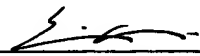
**SUBMISSION OF CORRECTED FORMAL DRAWINGS**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowability dated February 27, 2006, submitted herewith are corrected formal drawings for Figures 6, 9, 10 and 25.

Respectfully submitted,

  
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